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A T S K

DONALD R. ANTONELLI  
MELVIN KRAUS  
WILLIAM I. SOLOMON\*  
GREGORY E. MONTONE  
RONALD J. SHORE  
DONALD E. STOUT  
ALAN E. SCHIAVELLI  
JAMES N. DRESSER  
CARL I. BRUNDIDGE\*  
PAUL J. SKWIERAWSKI\*  
HUNG H. BUI\*  
ALFRED A. STADNICK\*  
\*ADMITTED OTHER THAN VA

LAW OFFICES  
**ANTONELLI, TERRY, STOUT & KRAUS, LLP**

SUITE 1800  
1300 NORTH SEVENTEENTH STREET  
ARLINGTON, VIRGINIA 22209

TELEPHONE (703) 312-6600  
FACSIMILE (703) 312-6666  
[hbui@antonelli.com](mailto:hbui@antonelli.com)

OF COUNSEL  
DAVID T. TERRY  
HAROLD A. WILLIAMSON\*

RANDALL S. SVIHLA  
GEORGE N. STEVENS\*  
FREDERICK D. BAILEY  
DAVID C. OREN  
RALPH T. WEBB\*  
STERLING W. CHANDLER\*

PATENT AGENT  
LARRY N. ANAGNOS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
**Attention: Examiner Jose R. Diaz**  
**Art Unit: 2815**

**December 19, 2003**

Re: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD FOR...**  
U.S. Application No.: 09/809,181  
Attorney Docket No.: 503.39864X00

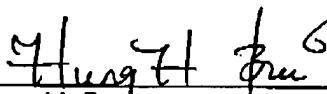
**SUBMISSION OF DOCUMENTS**

Sir:

Applicants hereby submit the attached "RESPONSE TO OUTSTANDING OFFICE ACTION" (20 pgs), "Petition for Extension of Time" and Credit Card Payment Form in the above-identified application.

**CERTIFICATE OF TRANSMISSION:**

I hereby certify that the attached "RESPONSE TO OUTSTANDING OFFICE ACTION" (20 pgs), "Petition for Extension of Time" and Credit Card Payment Form prepared in response to the Office Action dated on June 19, 2003, is being formally filed in the USPTO via Group 2815; Examiner Jose R. Diaz; Facsimile No. 703-872-9306 on **December 19, 2003**.

  
Hung H. Bui

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Toshiya SATOH et al.  
Serial No.: 09/809,181  
Filed: March 16, 2001  
For: **SEMICONDUCTOR DEVICE AND MANUFACTURING  
METHOD FOR HIGH RELIABILITY AND PRODUCTION YIELD  
RATE WITH MINIMAL DAMAGE DUE TO APPLICATION OF  
MECHANICAL STRESS AND THERMAL STRESS**  
Group: 2815  
Examiner: Jose R. Diaz

**RESPONSE TO OUSTANDING OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 19, 2003

Sir:

In response to the non-final Office Action (Paper No. 23) dated on June 19, 2003, please consider and enter the arguments and remarks in the above-identified application as follows.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.